



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Henry A. Hill  
Serial No. : 10/734,994  
Filed : December 12, 2003  
Title : IN-PROCESS CORRECTION OF STAGE MIRROR DEFORMATIONS  
DURING A PHOTOLITHOGRAPHY EXPOSURE CYCLE

Art Unit : 2851  
Examiner : Peter B. Kim

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF APRIL 14, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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8-12-05  
Date of Deposit

Signature

Typed or Printed Name of Person Signing Certificate

*Cheryl A. Caron*

CHERYL A. CARON